

VIA EFS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:	§	
Takashi ITO, et al.	§	
	§	
Conf. No.: 8148	§	Group Art Unit: 1795
	§	
Appln. No.: 10/562,098	§	Examiner: Anca Eoff
	§	
Filing Date: December 21, 2005	§	Attorney Docket No.: 9369-114US
	§	(T37-196236C)
Title: ACTINIC RADIATION –CURABLE STEREOLITHOGRAPHIC RESIN COMPOSITION HAVING IMPROVED STABILITY		

PETITION FOR EXTENSION OF TIME UNDER (37 C.F.R. § 1.136(a))

Applicant(s) in the above-identified application hereby petition(s) for a two-month extension of time to and including January 12, 2010 for responding to the Office Action mailed August 12, 2009. An Amendment accompanies this Petition.

☐ A check in the amount of \$ __.00 is enclosed herewith.

☒ The Commissioner is hereby authorized to charge Deposit Account No. 50-1017 (**Billing No. 209369.0114**) as noted below.

☒ Extension fee in the amount of \$490.00

☒ Any deficiencies or overpayments in the above-calculated fee.

Respectfully submitted,
Takashi Ito, et al.

January 6, 2010
(Date)

By: /Sandra M. Katz/

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